

SEP 1 6 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

blicant: Anis Zribi et al.

Group Art Unit: 2855

Serial No.: 10/719,971

Examiner: M. Cygan

Filed: November 21, 2003

For MINIATURIZED MULTI-GAS AND VAPOR SENSOR DEVICES AND ASSOCIATED

ALEXANDRIA, VA 22313-1450

METHODS OF FABRICATION

INFORMATION DISCLOSURE STATEMENT

1	Pursuant to 37CFR 1.97(b) [within 3 months of national, non-CPA filling or prior to 1st Office Action] no charge
X 2	Certification Pursuant to 37 CFR 1.97(c)(1)
	[before Final Office Action, Allowance, or other action closing prosecution] no charge
3	Fee Payment Pursuant to 37 CFR 1.97(c)(2) [before Final Office Action, Allowance, or other action closing prosecution] \$180.00
□ 4	Certification & Fee Payment Pursuant to 37 CFR 1.97(d)
<u> </u>	[On or before issue fee payment] \$180.00
ATTN:	Mail Stop AMENDMENT
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Sir:

The following are submitted in the above application in compliance with 37 CFR 1.97 and 37 CFR 1.98:

☑ 5 A list of documents on form PTO-1449 or Substitute together with copies of each identified document and a translation thereof or a concise explanation of each non-English language document or a Search Report from an International Searching Authority for a patent application filed via the Patent Cooperation Treaty or document(s) cited in the application or the priority application.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, on the date indicated below.
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This paper is sul	bmitted in	n accordance with:	
	37 CF Action		nonths of national, non-CPA filing or prior to 1st Office
⊠ 7		FR 1.97(c): [before Fing prosecution, whiche	nal Office Action, Allowance, or other action ever is earlier]; and
	X 8	The required Certifica	ation made in item 11 below;
	<u> </u>		cified in 37 CFR 1.17(p) for submission of osure Statement is authorized in item 15 below.
1	0 37 CI	R 1.97(d): [on or befo	ore issue fee payment]; and
	a)	The required Certifica	tion is stated in item 11 below; and
	b)	-	cified in 37 CFR 1.17(p) for submission of osure Statement is authorized in item 14 below.
□ 1	1 Certif	ication	
	<u> </u>	any communication	tion contained in this Statement was first cited in from a foreign patent office in a counterpart cation not more than three months prior to the nt; or
	□ 13	from a foreign patent to the knowledge of reasonable inquiry, Statement was kno	this Statement was cited in a communication of office in a counterpart foreign application and, the person signing this document after making no item of information contained in this wn to any individual designated in 37 CFR nree (3) months prior to the filing date of this
⊠ 1	4 Paym	ent of all applicable fe	ees:
	X 15	•	oplicable fees associated with the submittal of closure Statement to Deposit Account No.
An original and t	wo (2) cc	pies of this document	are enclosed.
	9/12/	05	Attorney - William E. Powell
General Electric C GEGR Patent Doc One Research Cir	ket Rm. I	3 Bldg. K-1 Rm. 4A59	Registration No. 39,803 Phone: (518) 387-4530 or (518) 387-7122

Niskayuna, New York 12309 Customer Number: 006147

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